



RESPONSE UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 2825  
Docket No.: 1076.1094

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Takashi KURIHARA, et al.

Serial No. 10/823,649

Group Art Unit: 2825

Confirmation No. 4917

Filed: April 14, 2004

Examiner: DOAN, NGHIA M.

For: METHOD AND APPARATUS DISTRIBUTION POWER SUPPLY PAD OF  
SEMICONDUCTOR INTEGRATED CIRCUIT (As amended)

**AMENDMENT AFTER FINAL REJECTION AND STATEMENT ON SUBSTANCE OF  
INTERVIEW**

Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

Attention: **BOX AF**

Sir:

This is in response to the Final Office Action mailed March 17, 2008, and having a period for response set to expire on June 17, 2008.

The following amendments and remarks are respectfully submitted. Reconsideration of the claims is respectfully requested.

OK TO ENTER: /N.D./

07/06/2008